

Search Notes

Application/Control No.

10/779,400

Examiner

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Applicant(s)/Patent under
Reexamination

IWAMURA, RYUICHI

Art Unit

2111

SEARCHED

Class	Subclass	Date	Examiner
710	305-317, 36-38, 62-64,72	7/15/2006	RP
709	201-203	7/15/2006	RP
725	219,74	7/17/2006	RP

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST	7/16/2006	RP